



MIT.9889

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Lee et al.

GROUP: 2815

SERIAL NO: 10/603,712

EXAMINER: A.R. Wilson

FILED: June 25, 2003

FOR: A METHOD FOR IMPROVING HOLE MOBILITY
ENHANCEMENT IN STRAINED SILICON P-TYPE
MOSFET

Mail Stop Amendment
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESPONSE

In response to the Office Action mailed February 22, 2004, please amend the above-identified application as follows: